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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Moreno, et al	
Serial No:	10/659,522	Group Art Unit: 1764
Filed:	9-9-2003	Examiner: Leung, Jennifer A.
For:	Apparatus and Method for Operating a Microreactor at High Pressure	Docket No. SP02-197

Commissioner of Patents
Alexandria, VA 22313-1450


Sir:

STATUS INQUIRY

Applicants hereby request the status of the above referenced pending application and a projected date for the next action.

25 July 2005
DateRespectfully submitted,
CORNING INCORPORATED

CERTIFICATE OF TRANSMISSION UNDER 37 C.F.R. § 1.8	
I hereby certify that this paper and any papers referred to herein are being transmitted by facsimile to the U.S. Patent and Trademark Office at 571-273-8300 on:	
<u>July 25, 2005</u> Date	
<u>Julie Hengshaw</u> Julie Hengshaw	<u>7/25/05</u> Date


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